## SERIAL NO. ATTY DOCKET NO. END920030116US1 INFORMATION DISCLOSURE CITATION Danicel C. Edelstein et al. (Use several sheets if necessary) **FILING** GROUP **U.S. PATENT DOCUMENTS** 'EXAMINER FILING DATE DOCUMENT NUMBER CLASS SUBCLASS DATE NAME IF APPROPRIATE INDA US2002/0172025 11/2002 Megahed et al. US2003/0067052 4/2003 Matsuo et al. US2002/0197844 12/2002 Johnson et al. 4/2003 6,551,931 Edelstein et al. 3/2003 6,534,374 Johnson et al. 10/2002 6,457,234 Edelstein et al. 9/2002 6,444,517 Hsu et al. 6,368,484 4/2002 Volant et al. 6,335,104 1/2002 Sambucetti et al. 12/2001 6,333,559 Costrini et al. 6,323,128 11/2001 Sambucetti et al. **FOREIGN PATENT DOCUMENTS** TRANSLATION DOCUMENT NUMBER DATE COUNTRY SUBCLASS YES 2/2003 WO03017479A2 **PCT** OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Research Disclosure, April 2000, AN ON-CHIP THREE-DIMENSIONAL INDUCTOR BY DAMASCENE PROCESS, pages 682-683. Burghartz et al., MONOLITHIC SPIRAL INDUCTORS FABRICATED USING A VLSI CU-DAMASCENE INTERCONNECT TECHNOLOGY AND LOW-LOSS SUBSTRATES, pages 4.5.1-4.5.4, 1996 IEEE. DATE CONSIDERED EXAM/NER: Initial if reference considered, whether or not citation is in conformance with MPEP 609/Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-A820 (also form PTO-1449)

## ATTY DOCKET NO. END920030116US1 INFORMATION DISCLOSURE CITATION Danicel C. Edelstein et al. (Use several sheets if necessary) FILING **U.S. PATENT DOCUMENTS** \*EXAMINER DOCUMENT NUMBER DATE NAME INITIAL 6,297,140 10/2001 Uzoh et al. 6,251,528 6/2001 Uzoh et al. 6,187,680 2/2001 Costrini et al. 6,133,136 10/2000 Edelstein et al. 6,114,937 9/2000 Burghartz et al.

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